

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Nobuhiro KOMINE)
) Group Art Unit: Not yet assigned
Application No.: Not Yet Assigned)
) Examiner: Not yet assigned
Filed: November 25, 2003)
)
For: RETICLE, EXPOSURE)
MONITORING METHOD,)
EXPOSURE METHOD AND)
MANUFACTURING METHOD)
FOR SEMICONDUCTOR)
DEVICE)

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicant brings to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicant respectfully requests that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed with the above-referenced application.

The following document is listed on the accompanying PTO-1449 and is in a non-English language.

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Japanese Patent (Laid-Open) Application No. 2002-025895 - This document discloses a measurement method of dose which is independent of focus. In particular, the dose value is checked by measurement of resist tin.

An English language abstract of this document is enclosed.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicant determines that the cited documents do not constitute "prior art" under United States law, applicant reserves the right to present to the office the relevant facts and law regarding the appropriate status of such documents. Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

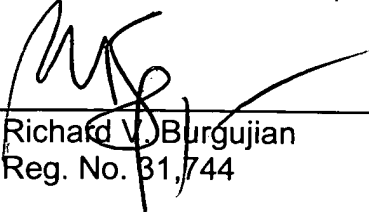
If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: November 26, 2003

By: _____


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Enclosures
RVB/FPD/sem

INFORMATION DISCLOSURE CITATION

Atty. Docket No.	03180.0342	Application No.	TBA
Applicant	Nobuhiro KOMINE		
Filing Date	November 25, 2003	Group:	Not yet assigned

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
	6,226,074 B1	05/01/2001	Fujisawa et al.	353	53	

FOREIGN PATENT DOCUMENTS

Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
2002-025895	01/25/2002	Japan			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	Date Considered
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce